

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Züger
SERIAL NO.: 10/530,994 GROUP NO.: 2823
FILING DATE: April 12, 2005 EXAMINER: W. David Coleman
TITLE: A Method For The Production Of A Substrate With A Magnetron
 Sputter Coating And Equipment For The Same

Commissioner for Patents
P.O. Box 1450
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AMENDMENT AND RESPONSE

The Applicants request entry of this Amendment and Response. The following remarks are responsive to the Office Action mailed on December 27, 2006 in the above-identified patent application. Consideration of the following remarks, and allowance of the claims, as presented, is respectfully requested. A two-month extension of time, up to and including May 27, 2007 is submitted herewith. Authorization to charge Attorney's charge card for the extension fee and any other proper fees is given in the EFS-Web filing submission papers

Amendments to the claims begin on page 2 of this paper.

Remarks are on page 8 of this paper.